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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of )  
Yasuhiro SHIMADA et al. ) Group Art Unit: 2815  
Serial No. 09/804,311 ) Examiner: E.J. Wojciechowicz  
Filed: March 13, 2001 )  
For: SEMICONDUCTOR DEVICE AND )  
METHOD FOR FABRICATING THE )  
SAME ) Docket No: 740819-520

**PETITION FOR WITHDRAWAL FROM ISSUE  
TO PERMIT CONSIDERATION OF INFORMATION  
DISCLOSURE STATEMENT**

RECEIVED  
OCT 10 2003  
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Mail Stop 313(c)  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


Sir:

Applicants hereby petition for the withdrawal of this application from issue. The issue fee for this case was paid on August 4, 2003.

The reason for withdrawal from issue of this application is for consideration of Information Disclosure Statement and Reasons for Rejection for a corresponding Japanese patent application

The petition fee of \$130 under 37 C.F.R. 1.17(i) is enclosed. The Commissioner is authorized to charge any deficiencies (except the issue fee) or credit any overpayment to Deposit Account No. 19-2380(740819-520). A duplicate copy of this sheet is attached.

11/03/2003 AKELLEY 00000029 09804311 Respectfully submitted,  
01 FC:1460 130.00 0P

  
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